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Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete If Known	
		Application Number	10/020813
		Filing Date	12-12-01
		First Named Inventor	Chakravarthi et al.
		Group Art Unit	2813
Examiner Name	THOMPSON		
Sheet 1 of 1	Attorney Docket No.	TI-33181	

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U.S. PATENT DOCUMENTS

Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
CAJ	AA	6,037,640	B1	Lee	03/14/2000	Entire Document
	AB					
	AC					
	AD					
	AE					
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FOREIGN PATENT DOCUMENTS

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
CAJ	CA	"Modeling Solid Source Boron Diffusion for Advanced Transistor Applications", P. PACKAN, S. THOMPSON, E. ANDIDEH, S. YU, M. GILES, J. SANDFORD and M. BOHR, 1998 IEEE, IEDM 98-505, 4 Pages.	
CAJ	CB	"Effect of fluorine on the diffusion of boron in ion implanted Si", Applied Physics Letters, 1998 American Institute of Physics, DANIEL F. DOWNEY, JUDY W. CHOW, EMI IISHIDA and KEVIN S. JONES, Volume 73, Number 9, August 31, 1998, 3 Pages.	
	CC		
	CD		
	CE		
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	CG		
	CH		

Examiner Signature	Date Considered
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Craig A. Thompson

9/18/02
9/6/04

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